



P/1596-74

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Hajime SHIRAKAWA et al.
Serial No.: 10/807,052
Filed: March 22, 2004

New York, New York
Date: July 13, 2004
Group Art Unit: 1762
Examiner: ---

For: SUBSTRATE TREATING METHOD AND APPARATUS

Commissioner for Patents
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Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

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Signature

July 13, 2004
Date of Signature

JAF:msd

Respectfully submitted,

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APPLICANT'S ART CITATION (Use several sheets if necessary)		Application Not Yet Known		OFGS File No. P/1596-74	
		Applicant Hajime SHIRAKAWA et al.			
		Filing Date March 22, 2004		Group Art Unit ---	

U.S. PATENT DOCUMENTS						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					

FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	8-10673	01-1996	Japan			x	
	2000-223464	08-2000	Japan			x	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		

Examiner	Date Considered
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